

Influence of impregnation times on the dispersion of CuO on anatase

Haiyang Zhu^a, Yong Wu^{a,c}, Xi Zhao^a, Haiqin Wan^a, Lijuan Yang^a, Jianming Hong^b,
Qing Yu^a, Lin Dong^{a,*}, Yi Chen^a, Can Jian^d, Jun Wei^d, Penghui Xu^d

^a Key Laboratory of Mesoscopic Chemistry of MOE, College of Chemistry and Chemical Engineering, China

^b Center of Modern Analysis, Nanjing University, Nanjing 210093, China

^c Department of Chemistry, Nanjing Normal University, Nanjing 210097, China

^d Department of Chemistry and Environment, Tibet University, Lhasa 850000, China

Received 25 May 2005; received in revised form 12 August 2005; accepted 12 August 2005

Available online 5 October 2005

Abstract

X-ray diffraction (XRD), temperature-programmed reduction (TPR) and X-ray photoelectron spectroscopy (XPS) were employed to investigate the dispersion of copper oxide in CuO/TiO₂ samples prepared by one and double-step impregnations and the NO + CO activities of CuO/TiO₂ samples were also tested. The results indicate that the dispersion capacity of copper oxide in CuO/TiO₂ samples with one-step impregnation and double impregnations are about 0.52 and 0.98 mmol/100 m² TiO₂, respectively, which should be related to the shielding effect of accompanying NO₃⁻ anions during the impregnations. Therefore, the dispersion capacity of copper oxide on anatase with double impregnations could approach to 1.16 mmol/100 m² TiO₂, i.e. a value corresponding to the density of vacant sites on the (001) surface of TiO₂. The NO + CO activities of CuO/TiO₂ samples suggest that dispersed copper oxide species in these catalysts is the mainly active species and the increasing amount of dispersed copper oxide would enhance their activities. It seems to suggest that, for the supported catalysts, double or multiple impregnations would result in better activity than those prepared by one-step impregnation. In addition, the coordination environment of the dispersed copper oxide species existed on the anatase surface has been discussed by the incorporation model [Y. Chen, L.F. Zhang, *Catal. Lett.* 12 (1992) 51].

© 2005 Elsevier B.V. All rights reserved.

Keywords: Copper oxide species; Anatase; Dispersion capacity; Impregnation; Incorporation model

1. Introduction

The interactions between metal oxide and oxide support have drawn much attention due to the wide applications of supported metal oxide catalysts, such as hydrodesulfurization, cracking, polymerization, partial oxidation of hydrocarbons and the selective reduction of nitrogen oxides. Accordingly, a large number of studies have been devoted to exploring the interaction between the support and the dispersed oxide species, and various explanations or models concerning the nature of the interaction have been proposed [1–7].

TiO₂ is a very important support widely used in heterogeneous catalysis. Transition metal oxides supported on TiO₂ have found application in various industrial reactions, such as V₂O₅/TiO₂ in selective oxidation of *o*-xylene to phthalic

anhydride [8], and the partial oxidation of hydrocarbons [9], CoO–MoO₃/TiO₂ for the hydrodesulfurization of hydrocarbon oils [10] and MoO₃/TiO₂ for the selective photooxidation of alcohol [11]. It is crucial for elucidating the nature of the catalysts and exploring the key factors in controlling the properties of the catalysts to investigate the interaction between the transition metal oxide and TiO₂ support.

The catalysts containing transition metals, especially copper, show a potential application for the treatment of exhaust gas from automobiles [12–15], complete oxidation of volatile organic compounds [16–19] and special attention has also been paid to this system as a substitute for noble metal containing catalysts recently [20]. Generally, three forms of the copper containing catalysts have been used for these investigations, e.g. unsupported copper oxide catalysts [21], supported copper oxide catalysts and supported metal copper catalysts [22,23]. As reported by Andersson and co-workers, the dispersed copper oxide on TiO₂ was active for the complete oxidation of CO and toluene. However, the presence of copper oxide species

* Corresponding author. Tel.: +86 25 83594945; fax: +86 25 83317761.
E-mail address: donglin@nju.edu.cn (L. Dong).

accelerates the sintering of TiO₂ support, which prohibits the application of these catalysts [18]. Xie et al. have investigated the dispersion of copper oxide on anatase and the influence of dispersed copper oxide on the phase transformation from anatase to rutile. Their results suggest that the dispersion capacity of copper oxide on anatase is about 4.0 Cu²⁺/nm² TiO₂, i.e. 0.66 mmol/100 m² TiO₂ [24]. Unfortunately, there was not a further explanation and discussion for their value of the dispersion capacity rather than other values. In the actual uses of the supported catalysts preparation, the dispersion capacity of the active species on a support is significant for us to consider the amount of the activity component. It is suggested that the surface coverage of a catalyst by the active component can be an index of catalytic activity [25]. The optimal content of the active component is often near its dispersion capacity [26–28]. For example, B.M. Reddy et al. approached the catalytic properties of MoO₃/TiO₂ by methanol oxidation, and results show that the highest conversion to formaldehyde is at 8 wt.% loading, which is close to the theoretical dispersion capacity of MoO₃ on titania (47 m²/g), i.e. 7.52 wt.% [28]. Many examples in catalytic applications suggest that the dispersion capacity be correlated with the catalytic properties intimately. So, measuring and discussing the dispersion capacities of supported catalysts is of obvious significance.

Recently, we have found that the dispersion amount of copper oxide on CuO/TiO₂ (anatase) varied with the impregnation times. However, the dispersion capacity of copper oxide on CuO/TiO₂ (anatase) was close to a fixed value, e.g. dispersion capacity and this result implied the fact that exploring the theoretical dispersion capacity of the supported catalysts should be significant. In this work, a series of CuO/TiO₂ with one-step and double-step impregnation have been prepared, and we will focus our attention on studying the influences of impregnation times on the dispersion of copper oxide on the anatase as well as the relationship of the dispersed copper oxide on titania (anatase) and the catalytic activities of NO + CO.

2. Experimental

2.1. Catalyst preparation

Anatase support was prepared via hydrolysis of titanium alkoxides, the product was washed, dried and then calcined in flowing air at 500 °C for 5 h [29]. The Brunauer–Emmett–Teller (BET) surface area is 77 m² g⁻¹.

CuO/TiO₂ samples with one-step impregnation were prepared by impregnating TiO₂ support with an aqueous solution containing the requisite amount of Cu(NO₃)₂, then dried at 100 °C followed by calcinations at 450 °C in air for 4 h. CuO/TiO₂ samples with double-step impregnation were prepared by impregnating CuO/TiO₂ with the copper oxide loading amount of 0.4 mmol/100 m² TiO₂ with the requisite amount of Cu(NO₃)₂, then dried at 100 °C followed by calcinations at 450 °C in air for 4 h. For the sake of simplicity, CuO/TiO₂ samples with one-step impregnation were signed as I-Cu-*x*, i.e. I-Cu-1.4 is corresponding to CuO/TiO₂ sample with one-step impregnation and CuO loading amount of 1.4 mmol/100 m²

TiO₂. CuO/TiO₂ samples with twice impregnation were signed as II-Cu-*x*.

2.2. Instrument

X-ray diffraction (XRD) qualitative and quantitative analysis were carried out on a Philips X'pert Pro diffractometer using Ni-filtered Cu K α radiation (0.15418 nm). The X-ray tube was operated at 40 kV and 40 mA.

Brunauer–Emmett–Teller surface areas were measured by nitrogen adsorption at 77 K on a Micromeritics ASAP 2000.

X-ray photoelectron spectroscopy (XPS) results were obtained by using a V.G. Escalab MK II spectrometer equipped with a hemispherical electron analyzer. The system was operated at 13 kV and 20 mA using a magnesium anode (Mg K α , $E = 1253.6$ eV). A binding energy (BE) of 284.5 eV for the C1s level was used as an internal reference.

Temperature-programmed reduction (TPR) was carried out in a quartz U-tube reactor, and 100 mg sample was used for each measurement. Prior to the reduction, the sample was pretreated in an N₂ stream at 100 °C for 1 h, and then cooled to room temperature. After that, H₂–Ar mixture (7% H₂ by volume) was switched on and the temperature was increased linearly at a rate of 10 °C min⁻¹. A thermal conductivity cell detected the consumption of H₂ in the reactant stream.

The activities of the catalysts for NO + CO reaction were carried out under steady state, involving a feed stream with a fixed composition, NO 3.33%, CO 6.67% and He 90% by volume as diluter. A quartz tube was employed as the reactor and the requisite quantity of catalysts (20 mg for each test) was used. The catalysts were pretreated in N₂ stream at 100 °C for 1 h, and then heated to reaction temperature, after that, the mixed gases were switched on. The reactions were carried out at 300 °C with the same space velocity of 30000 ml g⁻¹ h⁻¹. Two volumes and thermal conduction detector (TCD) were used for the purpose of analyzing the production, volume A with Porapak Q for separating N₂O and CO₂, and volume B with 13 \times molecular sieve (30–60 M) for separating N₂, NO and CO.

3. Results and discussion

Fig. 1 shows the XRD results of a series of I-Cu-*x* samples of different copper oxide loading amounts with one-step impregnation. For CuO/TiO₂ samples with low copper oxide loading amount, such as I-Cu-0.2 sample, there are no typical diffraction peaks of crystalline CuO in the pattern of Fig. 1a, except those of TiO₂ support. The typical peaks of crystalline CuO appear when the copper oxide loading amounts are beyond 0.6 mmol CuO/100 m² TiO₂, which indicates that crystalline CuO formed in these samples. The straight line determined by XRD quantitative analysis representing the relationship of $I_{\text{CuO}}/I_{\text{TiO}_2}$ versus the copper oxide loading amount gives an intercept corresponding to the dispersion capacity of copper oxide on TiO₂ [30,31], and the results show that the dispersion capacity of copper oxide on TiO₂ with one-step impregnation is about 0.52 mmol CuO/100 m² TiO₂, as shown in Fig. 2, which approximate to the quantitative results in reference [24].

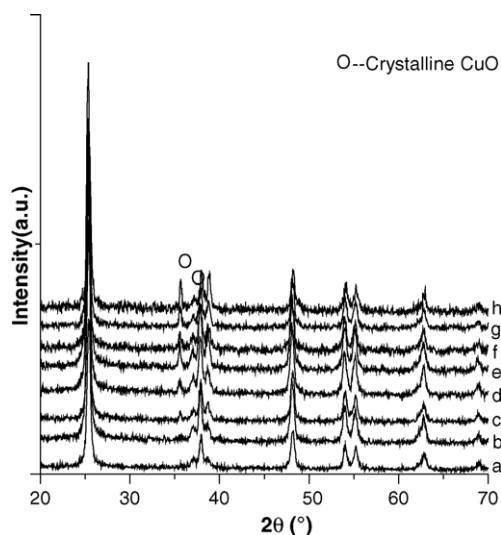


Fig. 1. (a–h) XRD patterns for I-Cu-*x* samples with copper oxide loading amounts of 0.2, 0.6, 1.0, 1.4, 1.8, 2.2, 2.5 and 3.0 mmol/100 m² TiO₂, respectively.

Fig. 3 shows the XRD results of a series of CuO/TiO₂ samples of different copper oxide loading amounts with double-step impregnation. When the copper oxide loading amount is below 0.8 mmol CuO/100 m² TiO₂, no typical characteristic peaks corresponding to crystalline CuO could be found in Fig. 3a and b. However, when the copper oxide loading amounts are beyond 1.4 mmol CuO/100 m² TiO₂, the characteristic peaks of crystalline CuO appeared in the patterns of Fig. 3e–f and their intensity increased with the copper oxide loadings. XRD quantitative results indicate that the dispersion capacity of copper oxide on anatase with double-step impregnation is about 0.98 mmol/100 m² TiO₂, as shown in Fig. 4. These results indicate that, for CuO/TiO₂ samples, the dispersion capacity of copper oxide on anatase with double-step impregnation is higher than that with one-step impregnation.

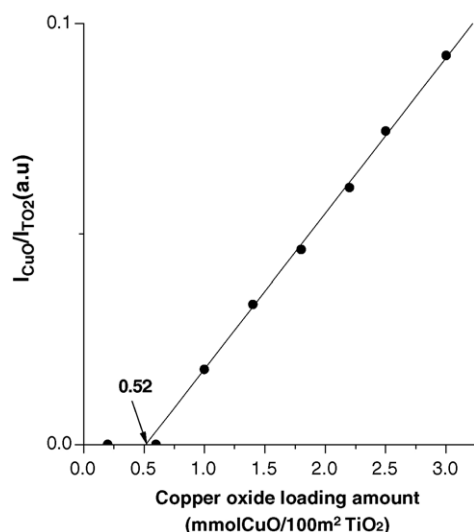


Fig. 2. Quantitative XRD results of I-Cu-*x* samples.

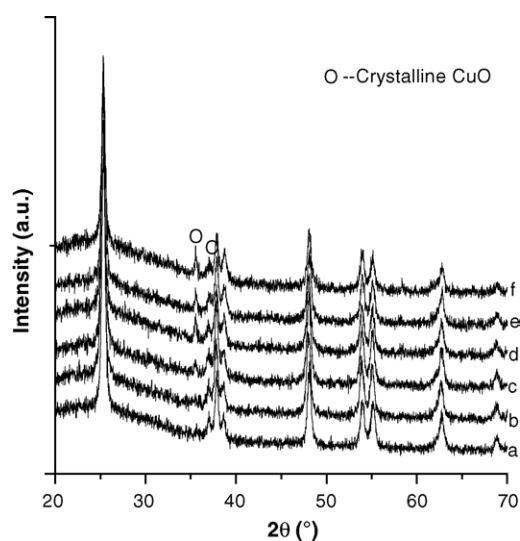


Fig. 3. (a–f) XRD patterns for II-Cu-*x* samples with copper oxide loading amounts of 0.4, 0.8, 1.4, 1.8, 2.2 and 2.6 mmol/100 m² TiO₂, respectively.

Figs. 5 and 6 show the TPR results of I-Cu and II-Cu samples, respectively. For these samples, when temperature is below 400 °C, two reduction peaks at about 165 and 230 °C can be detected, which could be attributed to the reduction of dispersed copper oxide and crystalline copper oxide, respectively [30]. For I-Cu and II-Cu samples, the peak area attributed to the reduction of dispersed copper oxide would reach the maximum with the copper oxide loading amount, while the area of the peak attributed to the reduction of crystalline CuO would increase with the copper oxide loading amount. When the copper oxide loading amount is beyond 2.2 mmol/100 m² TiO₂, it could be seen in Figs. 5f–g and 6e–f that the low temperature peak area almost keep stable. Quantitative analysis of the TPR results of these four samples, i.e. I-Cu-2.2, I-Cu-3.0, II-Cu-2.2 and II-Cu-2.6, has been carried out. Table 1 presents the proportion of two reduction peak areas in these four samples. As presented in Table 1, the dispersion capacities of copper

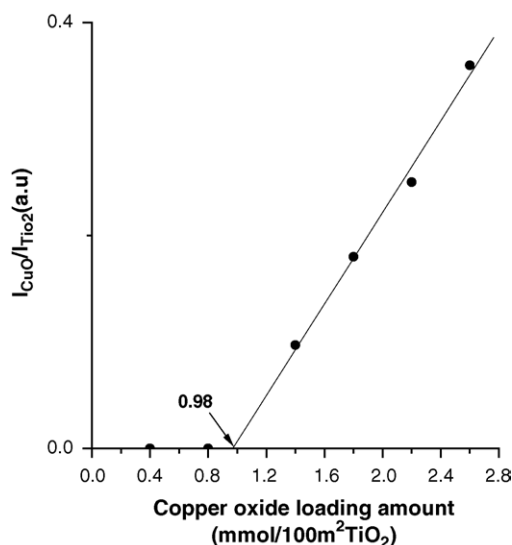


Fig. 4. Quantitative XRD results of II-Cu-*x* samples.

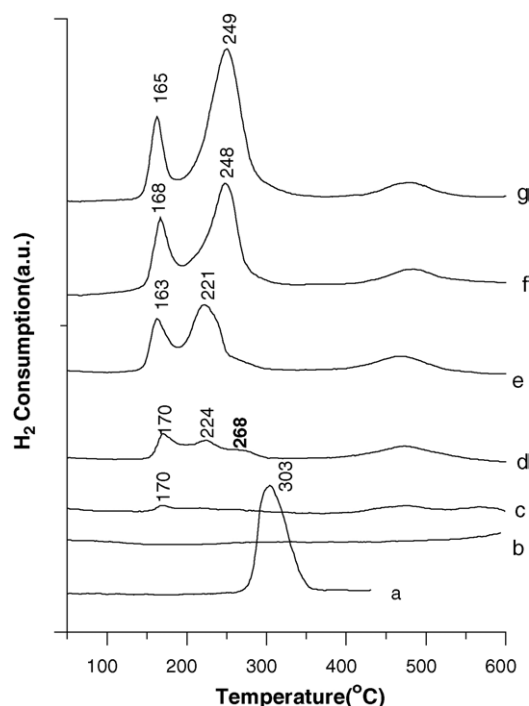


Fig. 5. TPR profiles of I-Cu-*x* samples: (a) pure CuO; (b) anatase; (c–g) copper oxide loading amounts of 0.2, 0.6, 1.4, 2.2 and 3.0 mmol/100 m² TiO₂, respectively.

oxide on anatase in I-Cu and II-Cu samples are about 0.54 and 0.92 mmol/100 m² TiO₂, which is basically consistent with XRD quantitative results, i.e. 0.52 and 0.98 mmol/100 m² TiO₂. In addition, it can be clearly seen that, for I-Cu samples, the reduction temperature of crystalline CuO shift from 224 to 249 °C

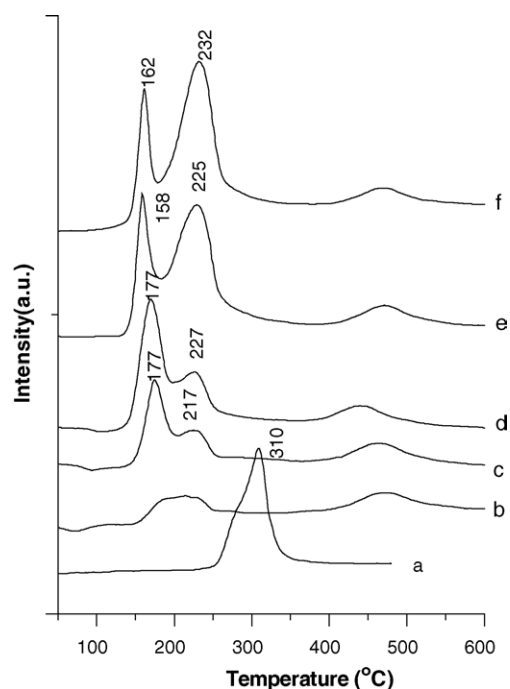


Fig. 6. TPR profiles of II-Cu-*x* samples: (a) pure CuO; (b–f) copper oxide loading amounts of 0.4, 0.8, 1.4, 2.2 and 2.6 mmol/100 m² TiO₂, respectively.

Table 1
Area percent of each reduction peak in TPR results

Sample	CuO loading (mmol/100 m ² TiO ₂)	Area (%)	
		Low temperature peak	High temperature peak
I-Cu	2.2	26.0	74.0
	3.0	17.3	82.7
II-Cu	2.2	40.5	59.5
	2.6	36.3	63.7

with the copper oxide loading amount increasing from 0.6 to 3.0 mmol/100 m² TiO₂, and the reduction temperature of crystalline CuO in II-Cu samples increase slightly with the copper oxide loading amount. This can be understood by taking into consideration that TiO₂ is an n-type semiconductor. Under a reducing atmosphere, TiO₂ tends to produce a high concentration of n-type defects, i.e. Ti³⁺ ions and oxygen vacancies on the surface, and by donating electric charges to the Cu²⁺ ions, the unstable surface Ti³⁺ ions are returned to Ti⁴⁺ and the reduction of copper oxide species is promoted [32–34]. So, the enhancement of the reducibility of copper oxide species should be related to the interaction between the copper oxide species with TiO₂ support. Apparently, compared with the unsupported crystalline CuO species, dispersed copper oxide species are in close contact with the surface of TiO₂, thus the strongest influence of TiO₂ and the lowest reduction temperature are expected. For crystalline CuO, the interaction between small CuO particle and anatase should be stronger than that between large CuO particle and anatase. Thus, the reducibility of small CuO particle is enhanced more.

Fig. 7 shows Cu2p_{3/2} XPS results of II-Cu-*x* samples. The Cu2p_{3/2} binding energy of copper oxide species in II-Cu samples shift from 932.1 to 933.8 eV with the copper oxide loading amount increasing from 0.4 to 2.6 mmol/100 m² TiO₂. Table 2 presents the Cu2p_{3/2} binding energy of some copper-containing compounds. It has been well established that for copper species

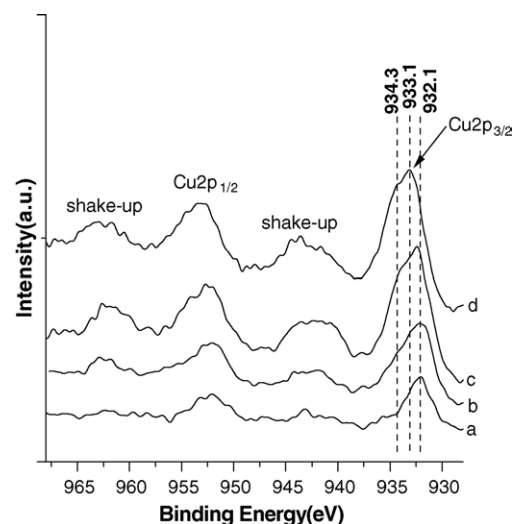


Fig. 7. Cu2p XPS spectra of II-Cu-*x* samples: (a–d) the copper oxide loading amount of 0.4, 0.8, 1.4 and 2.2 mmol/100 m² TiO₂, respectively.

Table 2
Binding energy of some compounds

Compound	Cu2p _{3/2} (eV)
CuO	934.4
Cu ₂ O	932.6

Cited from [41].

the presence and absence of the shake-up peak are the characteristic for Cu²⁺ species and Cu⁺ species [35]. As shown in Fig. 7, the intensity of the Cu2p_{3/2} shake-up peak of II-Cu samples increases with the copper oxide loading amount. And the Cu2p_{3/2} binding energies of copper species in II-Cu-0.4 and II-Cu-0.8 are about 932.1 eV, which is similar to the Cu⁺ in Cu₂O. This result seems to suggest that copper species in these two samples mainly exist as Cu⁺ species. However, the Cu2p_{3/2} binding energies of copper species in II-Cu-1.4 and II-Cu-2.2 are about 933.1 and 934.3 eV, close to the Cu²⁺ and the shake-up peak can be observed evidently, which should be attributed to the dispersed copper species and crystalline CuO. The result suggests that copper species mainly exist as the Cu²⁺ species and the crystalline CuO can be detected in II-Cu-1.4 and II-Cu-2.2. These results also indicate that the dispersion capacity of copper oxide on anatase with double impregnations is higher than 0.8 mmol/100 m² TiO₂ and lower than 1.4 mmol/100 m² TiO₂. As reported by Andersson and Larsson [19], dispersed Cu²⁺ species on anatase would be reduced to Cu⁺ species during the XPS measurement and the amount of Cu⁺ species would increase with the analysis time. Therefore, the creation of Cu⁺ species should be related to the reduction of dispersed Cu²⁺ species. In addition, for II-Cu-1.4 and II-Cu-2.2 samples, the Cu2p_{3/2} binding energy of dispersed Cu²⁺ species is about 933.1 eV, which is lower than that of Cu²⁺ ions in crystalline CuO, 934.3 eV. The shift might be related to the intensity of Cu–O bond, i.e. the intensity of Cu–O bond of dispersed Cu²⁺ species in CuO/TiO₂ sample might be weaker than that of Cu²⁺ in crystalline CuO.

Shown in Fig. 8 are the NO + CO activity and N₂ selectivity of a series of I-Cu and II-Cu samples. For I-Cu-*x* samples, the NO + CO activities decrease slowly with the presence of crystalline CuO. When the copper oxide loading amounts are lower than its dispersion capacity on anatase with double impregnations, such as II-Cu-0.4 and II-Cu-0.8 samples, the NO + CO activity and N₂ selectivity increase with the copper oxide loading; when the copper oxide loading amounts are beyond its dispersion capacity on anatase, such as II-Cu-1.4 and II-Cu-2.2 samples, the NO + CO activity keeps stable and the N₂ selectivity decreases slightly with the copper oxide loading amounts. The activity increases with the amount of dispersed copper oxide, indicating that dispersed copper oxide species might be the active species in these catalysts at current conditions. Therefore, it could be concluded that increasing the dispersed copper oxide amount could enhance the activities of these catalysts.

Xie et al. have investigated the influence of different precursors on the dispersion capacity of NiO and MoO₃ on γ-Al₂O₃. The results suggest that as a relatively low melting point oxide, MoO₃ gives out a higher dispersion capacity than its precursor

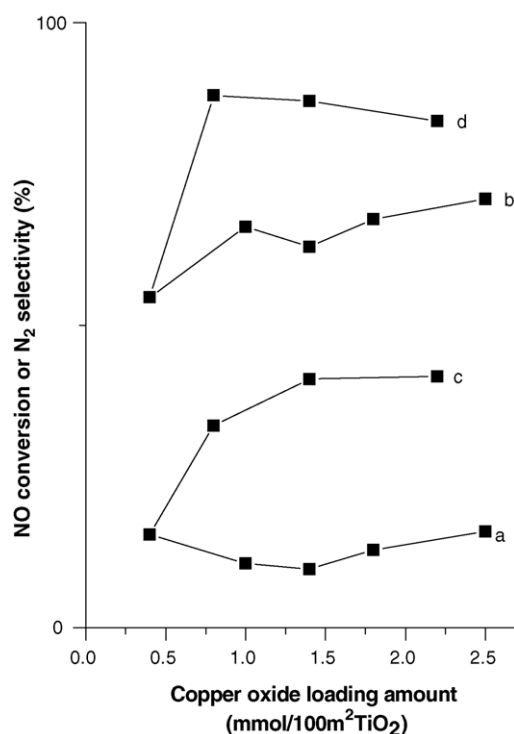


Fig. 8. Relationship between the NO conversions or the N₂ selectivity and the copper oxide loading amount: (a and c) the NO conversion of I-Cu-*x* and II-Cu-*x*; (b and d) the N₂ selectivity of I-Cu-*x* and II-Cu-*x* samples, respectively.

or molybdate used for impregnations; as a high melting point oxide, the dispersion capacity of NiO is the same as that of its precursors [36]. Along this line, the dispersion capacity of CuO on anatase should be related to the dispersion capacity of Cu(NO₃)₂. As discussed previously [29,37], the (001) plane of the TiO₂ (anatase) is considered the preferentially exposed plane, the dispersion capacity and the surface states of the active species could be expected by considering the surface structure of TiO₂. For anatase, the vacant site density in (001) plane is about 1.16 mmol/100 m², shown in Fig. 9a. When anatase was impregnated by Cu(NO₃)₂ aqueous solution, Cu²⁺ ions would occupy the vacant site on anatase surface and the two accompanying NO₃⁻ anion would stay at the top of the occupied site as capping NO₃⁻, compensating the extra positive charge. As reported elsewhere [38], the effect radius and area of NO₃⁻ is about 0.19 nm and 0.125 nm², respectively. The two accompanying NO₃⁻ anion would prevent some of the neighboring vacant sites on the surface of anatase from being incorporated by other copper ions, as shown in Fig. 9b. Considering this shielding effect of capping NO₃⁻ anion, when the NO₃⁻ anions form a close-pack monolayer on the anatase surface, the dispersion capacity of Cu(NO₃)₂ on anatase is about 0.66 mmol/100 m² TiO₂. During the calcinations, dispersed Cu(NO₃)₂ would decompose and form dispersed CuO species and those vacant sites shielded by capping NO₃⁻ anion would expose on the surface of anatase, and the excess of Cu(NO₃)₂ in these samples would decompose and might mainly form crystalline CuO. Accordingly, for the CuO/TiO₂ samples with one-step impregnation, the dispersion capacity of

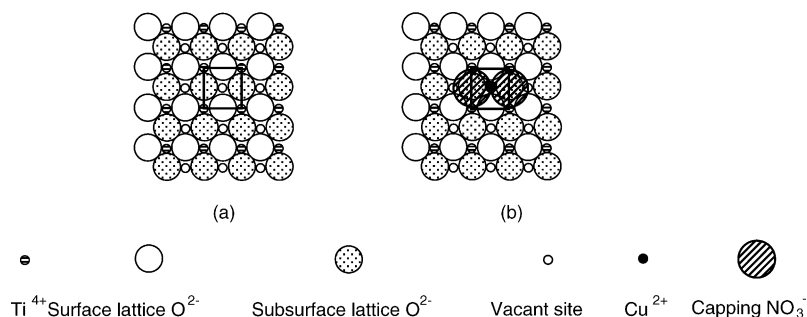


Fig. 9. The schematic diagram for the incorporated Cu^{2+} ions in the surface vacant sites on the (001) plane of TiO_2 (anatase): (a) (001) plane of TiO_2 (anatase) and (b) incorporation of the dispersed Cu^{2+} species accompanying with two NO_3^- anions on the (001) plane of TiO_2 (anatase) support.

copper oxide on anatase is basically equal to the dispersion capacity of $\text{Cu}(\text{NO}_3)_2$ on anatase, i.e. about $0.66 \text{ mmol}/100 \text{ m}^2 \text{ TiO}_2$. This is different from other systems, such as CuO/CeO_2 , $\text{CuO}/\gamma\text{-Al}_2\text{O}_3$, etc. In CuO/CeO_2 , $\text{CuO}/\gamma\text{-Al}_2\text{O}_3$ systems, the excess of $\text{Cu}(\text{NO}_3)_2$ might decompose and form dispersed copper oxide species on the surface of support, thus copper oxide monolayer dispersion on these support could be reached after one-step impregnation [39,40]. The different behavior of the excess of $\text{Cu}(\text{NO}_3)_2$ between in CuO/TiO_2 system and other systems might be related to the difference of the interaction extent between the dispersed copper oxide species and the support. For I-Cu-0.4 support after calcinations, the vacant site unoccupied by Cu^{2+} ions is around $0.76 \text{ mmol}/100 \text{ m}^2 \text{ TiO}_2$, which can be expected by the incorporation model. When I-Cu-0.4 was impregnated one more time by $\text{Cu}(\text{NO}_3)_2$ aqueous solution, $\text{Cu}(\text{NO}_3)_2$ would occupy those remained vacant sites on the surface of I-Cu-0.4. Similarly, considering the shielding effect of capping NO_3^- anion, the dispersion capacity of $\text{Cu}(\text{NO}_3)_2$ on I-Cu-0.4 is about $0.66 \text{ mmol}/100 \text{ m}^2 \text{ TiO}_2$. After calcinations, the dispersion capacity of copper oxide on anatase is about $1.06 \text{ mmol}/100 \text{ m}^2 \text{ TiO}_2$, which is basically coincided with the XRD and quantitative TPR results.

4. Conclusion

Double-step impregnation could enhance the dispersion capacity of copper oxide on the surface of anatase and the maximal monolayer dispersion capacity of copper oxide on the surface of anatase is $1.16 \text{ mmol}/100 \text{ m}^2 \text{ TiO}_2$, which is expected by incorporation model. The activities of CuO/TiO_2 catalysts for $\text{NO} + \text{CO}$ reaction at 300°C are close related to disperse copper oxide species. It could be predicted that the CuO/TiO_2 catalysts with double and multiple impregnations would show the better activity than those with one-step impregnations.

Acknowledgements

The financial supports of the Special of Foundation for the Doctor-subject of China (No. 20030284002) and the National Basic Research Program of China (Grant No. 2003CB615804) are gratefully acknowledged.

References

- [1] H.P. Boehm, H. Knozinger, in: J.R. Anderson, M. Boudart (Eds.), *Analysis, Science and Technology*, vol. 4, Springer-Verlag, West Berlin, 1983, p. 39.
- [2] Y.I. Yermakov, B.N. Kuznetsov, V.A. Zakharov, *Analysis by Supported Complexes*, Elsevier, Amsterdam, 1981.
- [3] B. Delmon, M. Houalla, in: B. Delmon, P. Grange, P.A. Jacobs, G. Pone- steplet (Eds.), *Preparation of Catalysts II*, Elsevier, Amsterdam, 1979, p. 447.
- [4] H. Knozinger, E. Taglauer, in: J.J. Spivey, S.K. Agarwal (Eds.), *Catalysis, A Specialist Periodical Report*, vol. 10, The Royal Society of Chemistry, London, 1993, p. 1.
- [5] F.E. Massoth, *Adv. Catal.* 27 (1978) 265.
- [6] L. Dong, Y. Hu, F. Xu, D. Lu, B. Xu, Z. Hu, Y. Chen, *J. Phys. Chem.* 104 (2000) 78.
- [7] L. Dong, Y. Hu, M. Shen, T. Jin, J. Wang, W. Ding, Y. Chen, *Chem. Mater.* 13 (2001) 4227.
- [8] B.L. Xu, Y.N. Fan, L. Liu, M. Lin, Y. Chen, *Sci. China Ser. B* 45 (2002) 407.
- [9] D.J. Cole, C.F. Cullis, D.J. Hucknall, *J. Chem. Soc. Faraday Trans. I* 72 (1976) 2185.
- [10] K.Y.S. Ng, E. Gulari, *J. Catal.* 92 (1985) 340.
- [11] Y.C. Liu, G.L. Griffin, S.S. Chan, *J. Catal.* 94 (1985) 108.
- [12] R.T. Rewick, H. Wise, *J. Catal.* 40 (1975) 301.
- [13] F. Boccuzzi, E. Guglielminotti, G. Martra, G. Cerrato, *J. Catal.* 146 (1994) 449.
- [14] M.C. Wu, D.W. Goodman, *J. Phys. Chem.* 98 (1994) 9874.
- [15] H. Knozinger, *Adv. Catal.* 25 (1976) 184.
- [16] G.C. Chinchin, K.C. Waugh, *J. Catal.* 97 (1986) 280.
- [17] T.H. Fleisch, R.L. Mieville, *J. Catal.* 97 (1986) 284.
- [18] P. Larsson, A. Andersson, L.R. Wallenberg, B. Svensson, *J. Catal.* 163 (1996) 279.
- [19] P. Larsson, A. Andersson, *J. Catal.* 179 (1998) 72.
- [20] P.Y. Lin, M. Skoglundh, L. Lowendahl, J.E. Otterstedt, L. Dahl, K. Jansson, M. Nygren, *Appl. Catal. B* 6 (1995) 237.
- [21] J.W. London, A.T. Bell, *J. Catal.* 31 (1973) 96.
- [22] R. Hierl, H.P. Urbach, H. Knozinger, *J. Chem. Soc. Faraday Trans.* 88 (1992) 355.
- [23] A.R. Balkenede, H. den Daas, M. Huisman, O.L.J. Gijzeman, J.W. Geus, *Appl. Surf. Sci.* 47 (1991) 341.
- [24] X. Yu, N. Wu, Y. Xie, Y. Tang, *J. Mater. Chem.* 10 (2000) 1629.
- [25] S. Rondon, M. Houalla, D.M. Hercules, *Surf. Interface Anal.* 26 (1998) 329.
- [26] K.V. Narayana, A. Venugopal, K.S. Rama Rao, S. Khaja Masthan, V. Venkat Rao, P. Kanta Rao, *Appl. Catal. A* 167 (1998) 11.
- [27] K.V. Narayana, A. Venugopal, K.S. Rama Rao, V. Venkat Rao, S. Khaja Masthan, P. Kanta Rao, *Appl. Catal. A* 150 (1997) 269.
- [28] B.M. Reddy, K. Narsimha, P. Kanta Rao, *Langmuir* 7 (1991) 1551.
- [29] H. Zhu, M. Shen, Y. Kong, J. Hong, Y. Hu, T. Liu, L. Dong, Y. Chen, C. Jian, Z. Liu, *J. Mol. Catal. A* 219 (2004) 155.

- [30] B. Xu, L. Dong, Y. Chen, *J. Chem. Soc. Faraday Trans.* 94 (1998) 1905.
- [31] Y.C. Xie, Y.Q. Tang, *Adv. Catal.* 37 (1990) 1.
- [32] S.J. Decanlo, T.M. Apple, C.R. Dybowski, *J. Phys. Chem.* 87 (1983) 194.
- [33] P. Meriaudeau, O.M. Ellested, C. Naccache, *J. Catal.* 75 (1982) 243.
- [34] D. Duprez, A. Miloudi, *Stud. Surf. Sci. Catal.* 11 (1982) 179.
- [35] D. Brigs, M.P. Seah (Eds.), *Practical Surface Analysis by Auger and X-ray Photoelectron Spectroscopy*, Wiley, New York, 1983.
- [36] X. Wang, B. Zhao, D. Jiang, Y. Xie, *Appl. Catal. A* 188 (1999) 201.
- [37] B. Xu, L. Dong, Y.N. Fan, Y. Chen, *J. Catal.* 193 (2000) 88.
- [38] J.T. Cheng, P.D. Ellis, *J. Phys. Chem.* 93 (1989) 2549.
- [39] L. Dong, Y. Jin, Y. Chen, *Sci. China Ser. B* 40 (1997) 24.
- [40] L. Dong, Y. Hu, M. Shen, T. Jin, J. Wang, W. Ding, Y. Chen, *Chem. Mater.* 13 (2001) 4227.
- [41] X. Jiang, L. Lou, Y. Chen, X. Zheng, *J. Mol. Catal. A Chem.* 197 (2003) 193.